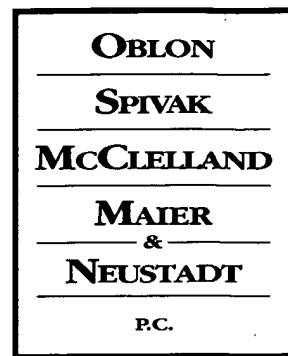




Docket No.: 240882US0



ATTORNEYS AT LAW

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

RE: Application Serial No.: 10/626,521  
Applicants: Tomohisa KONNO, et al.  
Filing Date: July 25, 2003  
For: AQUEOUS DISPERSION FOR CHEMICAL  
MECHANICAL POLISHING AND PRODUCTION  
PROCESS OF SEMICONDUCTOR DEVICE

SIR:

Attached hereto for filing are the following papers:

**Letter; Copy of the following: (Specification (54 pp.), 8 Claims/Drawings 0 Sheets and 3 pages  
Application Data Sheet; Combined Declaration, Petition & Power of Attorney (Executed (4 pp.));  
Utility Patent Application Transmittal; Request for Priority; Priority Document (1))**

Our check in the amount of \_\_\_\_\_ is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

Norman F. Oblon

J. Derek Mason

Registration No. 35,270

Customer Number

**22850**

(703) 413-3000 (phone)

(703) 413-2220 (fax)



DOCKET NO.240882US0

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

Tomohisa KONNO, et al. :

SERIAL NO: 10/626,521 :

FILED: July 25, 2003 :

FOR: AQUEOUS DISPERSION FOR CHEMICAL MECHANICAL POLISHING AND  
PRODUCTION PROCESS OF SEMICONDUCTOR DEVICE

LETTER

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

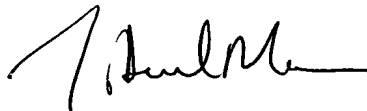
SIR:

Enclosed herewith is a complete copy of the filing papers originally submitted on July  
25, 2003.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

Norman F. Oblon



J. Derek Mason

Registration No. 35,270

Customer Number

**22850**

(703) 413-3000 (phone)

(703) 413-2220 (fax)



*ME*

OSMM&N File No. 240882US0

Serial No. NEW APPLICATION

In the matter of the Application of: Tomohisa KONNO, et al.

For: AQUEOUS DISPERSION FOR CHEMICAL MECHANICAL POLISHING  
AND PRODUCTION PROCESS OF SEMICONDUCTOR DEVICE

Dept.: PP/JF

By: NFO/dlb

**Due Date: 07/25/02**

The following has been received in the U.S. Patent Office on the date stamped hereon:

- 54 pp. Specification 8 Claims/Drawings 0 Sheets and  
3 Pages Application Data Sheet
- Combined Declaration, Petition & Power of Attorney 4 Pages
- Utility Patent Application Transmittal
- Request for Priority
- Priority Doc (1)
- Check for \$1,030.00
- Dep. Acct. Order Form
- White Advance Serial Number Card

